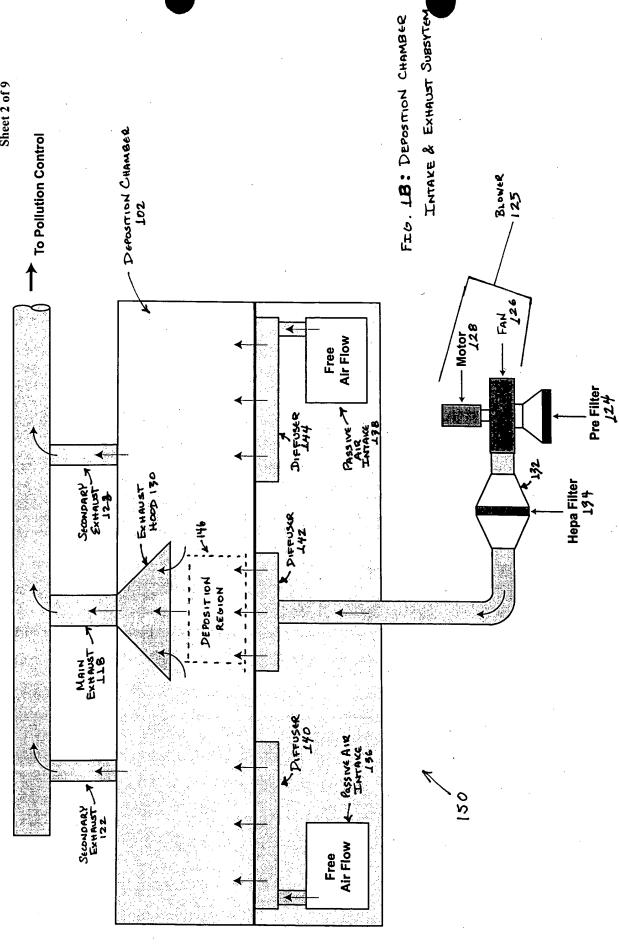
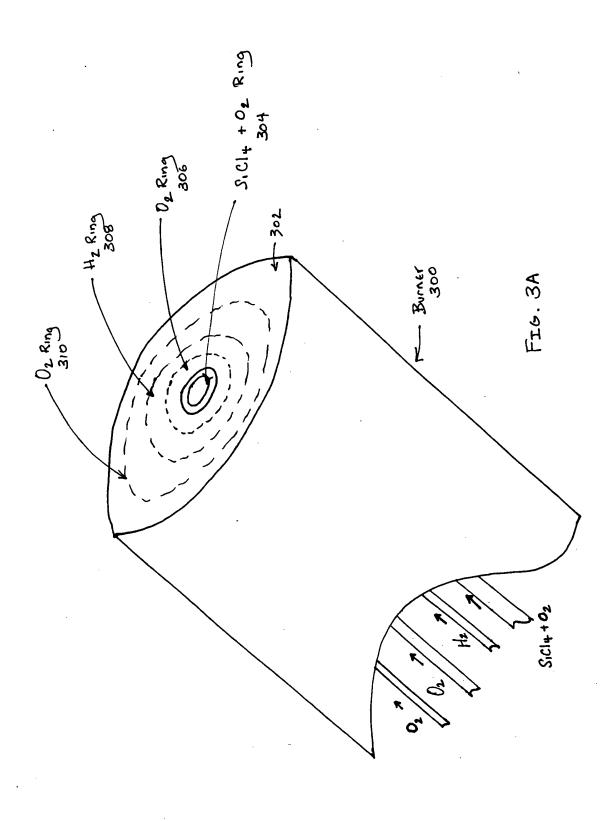
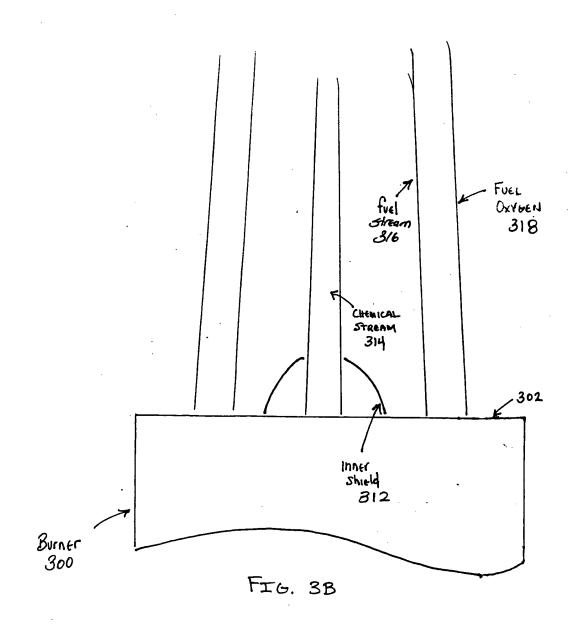
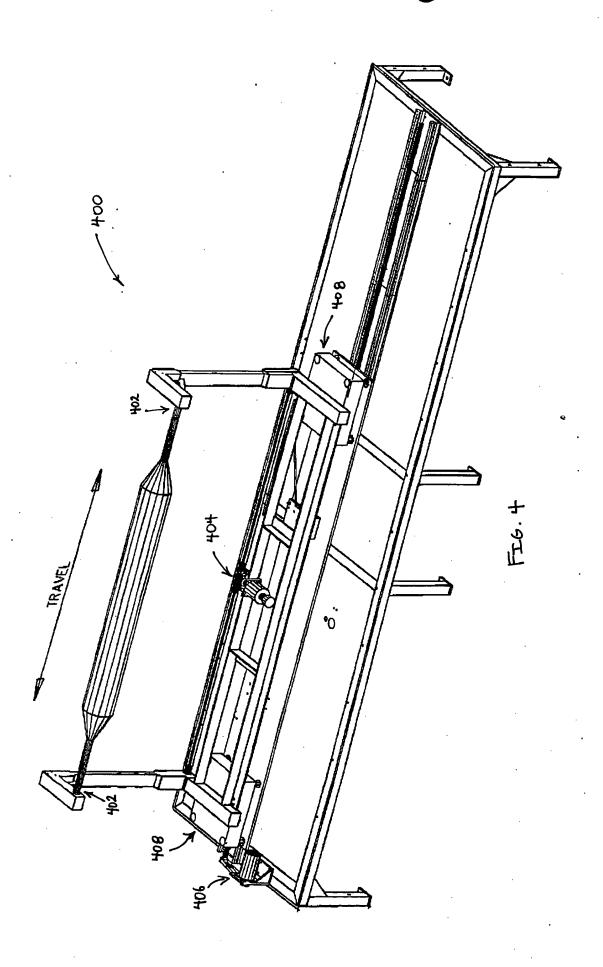


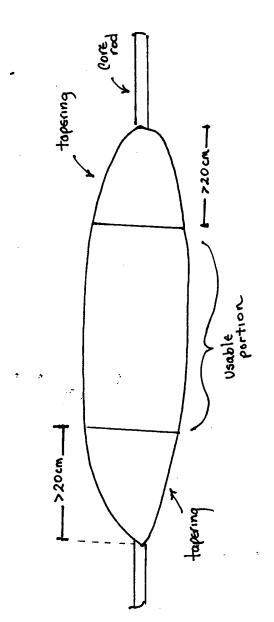
VAPOR DEPOSITION SYSTEM











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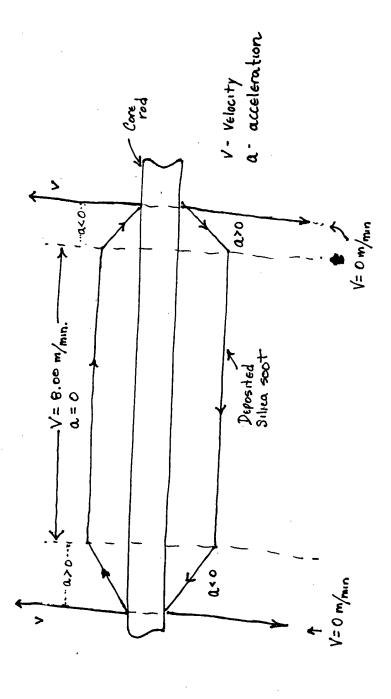


FIG. 6

700

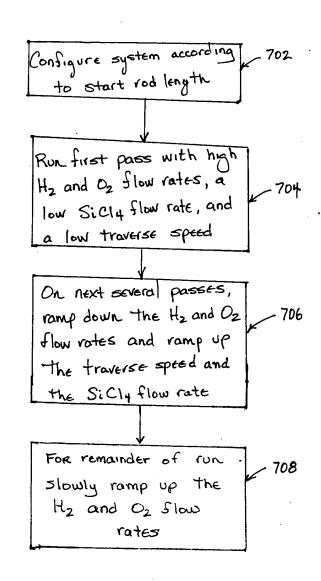


FIG. 7: DEPOSITION PROCESS